

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :
Paul RICH et al. :
Serial No. [NEW] :
Filed: January 21, 2004 :
For: ELECTROSTATIC CLAMPING OF THIN WAFERS IN PLASMA
PROCESSING VACUUM CHAMBER

PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, Mail Stop Patent Application
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

Preliminary to the examination of the above-identified application,
please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which
begins on page 3 of this paper.

Remarks begin on page 5 of this paper.